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CONFIRMATION NO. 7281

<b>SERIAL NUMBER</b> 10/517,655	<b>FILING OR 371(c) DATE</b> 12/13/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 122035	
<b>APPLICANTS</b> Masakazu Sato, Fukushima, JAPAN; Masato Onishi, Fukushima, JAPAN;  <b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/07320 06/10/2003  <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002173268 06/11/2002					
Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 132	<b>INDEPENDENT CLAIMS</b> 2
Verified and Acknowledged Examiner's Signature _____ Initials _____					
<b>ADDRESS</b> 25944					
<b>TITLE</b> Semiconductor wafer shape evaluating method and shape evaluating device					
<b>FILING FEE RECEIVED</b> 6600	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		